

# **Knobbe Martens Olson & Bear LLP**

*Intellectual Property Law*

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3 October 2007

Attn: Certificate of Correction Branch  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: USA Patent 7,238,595, issued 3 July 2007  
"Epitaxial Semiconductor Deposition Methods and Structures"  
Our Reference ASMEX.448A

Dear Sir:

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP



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Enclosure

4358322  
100307

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**UNITED STATES PATENT AND TRADEMARK OFFICE  
CERTIFICATE OF CORRECTION**

Page 1 of 1

PATENT NO. : 7,238,595

APPLICATION NO.: 10/800,390

ISSUE DATE : July 3, 2007

INVENTOR(S) : Paul D. Brabant; Joseph P. Italiano; Chantal J. Arena; Pierre Tomasini; Ivo Raaijmakers; and  
Mathias Bauer

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On Page 2, Col. 1 of List of References, delete "Domonstration" and insert -- Demonstration --, therefore.

On Page 2, Col. 1 of List of References, delete "high-kgate" and insert -- high-k gate --, therefore.

On Page 2, Col. 2 of List of References, delete ""Schollhorn et al., "Coalescence of germanium islands on silicon", Thin Solid Films 336:109-111 (1998)."

In Col. 22, line 36, delete "heteroeptitaxial" and insert -- heteroeptitaxial --, therefore.

In Col. 22, line 60, delete "trisine" and insert -- trisilane --, therefore.

In Col. 23, line 17, delete "Torn" and insert -- Torr --, therefore.

**MAILING ADDRESS OF SENDER (Please do not use customer number below):**

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This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: **Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

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